

**REPLY UNDER 37 CFR § 1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER 1600**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:**

Kirby *et al.*

**Serial No.:** 10/804,366

**Filed:** March 19, 2004

**For:** METHODS OF SELECTIVELY  
REMOVING SILICON (as amended)

**Confirmation No.:** 9222

**Examiner:** T. Pham

**Group Art Unit:** 2813

**Attorney Docket No.:** 2269-6208US  
(03-0852.00/US)

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September 10, 2007

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**AMENDMENT UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Examiner:

The following amendments and remarks are filed in response to the Examiner's remarks in the Final Office Action mailed July 9, 2007, the three-month shortened statutory period for response to which expires on October 9, 2007. This response is submitted on or before two months from the mailing date of the Final Office Action.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.